

FORM PTO-1449 U.S. Department of Commerce  
(Rev. 4/92) Patent and Trademark Office

ATTY. DOCKET NO.  
8674.023.US0000

APPLICATION NO.  
10/516,888

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use several sheets if necessary)

APPLICANT  
Paul Alexander DE VRIES et al.

FILING DATE  
December 3, 2004

GROUP  
1793

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
													YES	NO

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

		Notice of Allowance, March 18, 2008, for US Patent Appln. No. 10/488,042 to DeVries
		Office Action, May 11, 2007, for US Patent Appln. No. 10/488,042 to DeVries
		Office Action, October 16, 2007, for US Patent Appln. No. 10/488,042 to DeVries
		Office Action, December 3, 2007, for US Patent Appln. No. 10/491,278 to DeVries
		Office Action, June 26, 2007, for US Patent Appln. No. 10/491,278 to DeVries
		Office Action, August 30, 2007, for US Patent Appln. No. 10/516,889 to DeVries et al.
		Office Action, January 31, 2008, for US Patent Appln. No. 10/516,889 to DeVries et al.
		Hanumanth et al., "Particle Sedimentation During Processing of Liquid Metal-Matrix Composites", Metallurgical Transaction B., Vol. 23B, pp. 753-763 (1992)
		L.C. Bartel et al., "An Electrical Resistivity Measurement in Molten Basalt During the 1983 Kilauea Eruption, Bull. Volcanol., Vol. 46.3, pp. 271-276 (1983)

EXAMINER

DATE CONSIDERED

**EXAMINER:** Initial if citation is considered, draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.